

03560.002157.1



PATENT APPLICATION

Receipt

3/B
B.H

6/10/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

MASAFUMI SANO ET AL.

Application No.: 10/046,903

Filed: January 17, 2002

For: METHOD OF PRODUCING
ZINC OXIDE THIN FILM,
METHOD OF PRODUCING
PHOTOVOLTAIC DEVICE
AND METHOD OF
PRODUCING
SEMICONDUCTOR DEVICE

Examiner: NYA

Group Art Unit: 1741

RECEIVED

JUN 05 2002

TC 1700

May 21, 2002

Commissioner for Patents
Washington, D.C. 20231

PRELIMINARY SUPPLEMENTAL AMENDMENT

Sir:

Prior to examination on the merits, please amend the above-identified application as follows.

IN THE SPECIFICATION

At page 1, after the title, please substituted the following paragraph. A marked up version, showing the changes made thereto, is attached.

--CROSS REFERENCE TO RELATED APPLICATION

bl